Attv. Dkt. No. AMAT/5617/CMP/CMP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 1765

Examiner: MACKEY, TERRENCE

In re Application of:

Hsu et al.

Serial No.: 09/939,323

Confirmation No.:

3877

Filed:

August 24, 2001

For:

METHOD FOR DISHING

REDUCTION AND FEATURE

PASSIVATION IN POLISHING

PROCESSES

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING 37 CFR 1.8

I hereby certify that this correspondence is being deposited on May 19, 2003 with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date

RESPONSE TO OFFICE ACTION DATED FEBRUARY 19, 2003

In response to the Office Action dated February 19, 2003, having a shortened statutory period for response set to expire on May 19, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/5617/CMP/CMP/BTP, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.